



*DAW*

Docket No. EATNP160US

03-IMP-035

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re **PATENT** application of:

Applicant: Mehran Asdigha et al.

Application No.: 10/840,186

For: MECHANICAL OSCILLATOR FOR WAFER SCAN WITH SPOT  
BEAM

Filing Date: May 6, 2004

Examiner: David A. Vanore

Art Unit: 2881

**REPLY TO OFFICE ACTION DATED DECEMBER 13, 2005**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully  
requested in view of the following remarks.